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(REG. PATENT AGENTS)

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wSir:

PTO

Assistant Commissioner for Patents Washington, D.C. 20231

R. E. Bushnell

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9 August 2001

INTELLECTUAL PROPERTY LAW

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Attorney Docket: P56539

09/925037 09/925037 08/09/01

Submitted herewith is the following patent application:

Inventor:

1) HWAN-CHUL RHO

2) SEOG-LAE CHO

3) HAE-TAEK YANG

Title:

CATHODE FOR ELECTRON TUBE AND METHOD OF

YES

PREPARING THE SAME

Please find attached hereto an application for patent which includes: Specification and Abstract, Claims, and a certified copy of the foreign priority document identified below:

Verified Showing of Small Entity Status: **NO**Drawings: Formal drawings, 6 sheets, Figures 1-8
Claim of priority under 35 U.S.C. §119:

** The Republic Of Korea Application No. 2000-58756 filed on 6 October 2000.

FEE (see formula below): CHECK IS NOT ENCLOSED

Sasic Fee \$355//10	\$ <u>/10.00</u>
Additional Fees:	
Total number of claims in excess of 20: times \$9/18.	\$ <u>0.00</u>
Number of independent claims in excess of 3: times \$40/80	\$ <u>0.00</u>
Multiple Dependent Claims \$135/270	\$ <u>0.00</u>
An Assignment is likewise enclosed: Recording Fee \$40	\$ <u>0.00</u>
Filing Non-English specification	
TOTAL FEES FOR THE ABOVE APPLICATION	\$710.00

Assistant Commissioner for Patents 9 August 2001 Page Two

Docket No.: P56539

Inventor:

1) HWAN-CHUL RHO

2) SEOG-LAE CHO

3) HAE-TAEK YANG

Title:

CATHODE FOR ELECTRON TUBE AND METHOD OF

PREPARING THE SAME

In view of the above, it is requested that this application be accorded a filing date pursuant to 37 CFR 1.53(b).

Please address all correspondence to:

Robert E. Bushnell 1522 K Street, N.W. Suite 300 Washington, D.C. 20005

Respectfully submitted,

Robert E. Bushnell

(Registration No. 27,774)

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PATENT P56539

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HWAN-CHUL RHO et al.

Serial No.:

to be assigned

Examiner:

to be assigned

Filed:

9 August 2001

Art Unit:

to be assigned

For:

CATHODE FOR ELECTRON TUBE AND METHOD OF PREPARING THE

SAME

CLAIM OF PRIORITY UNDER 35 U.S.C. §119

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

The benefit of the filing date of the following prior foreign application, Korean Priority No. 2000-58756 (filed in Korea on 6 October 2000) filed in the U.S. Patent and Trademark Office on 9 August 2001, is hereby requested and the right of priority provided in 35 U.S.C. §119 is hereby claimed.

In support of this claim, filed herewith is a certified copy of said original foreign application.

Respectfully submitted,

Robert E. Bushnell Reg. No.: 27,774

Attorney for the Applicant

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Folio: P56539 Date: 9 August 2001 I.D.: REB/sb